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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE SEP 20 2007

Applicant(s): Wang

Application No.: 10/723,746

Filed: 11/25/2003

Title: POLISHING COMPOSITION FOR CMP
HAVING ABRASIVE PARTICLES

Attorney Docket No.: 03049US

Art Unit:
1765Examiner:
L. Umez EroniniCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450RESPONSE

Dear Sir:

In response to the Office Action of May 3, 2006, having a shortened statutory deadline extended by the petition to revive, please amend this application as follows: